

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Geiss, et al

Examiner: Malsawma, Lalrinfamkim hmar

Serial No.:

Art Group Unit: 2825

Filed: Herewith

Title: METHOD OF CONTROLLING GRAIN SIZE IN A POLYSILICON LAYER  
AND IN SEMICONDUCTOR DEVICES HAVING POLYSILICONE  
STRUCTURES

Commissioner for Patents  
Alexandria, VA 22313-1450

**PRELIMINARY AMENDMENT**

Sir:

In connection with filing the above-identified application, Applicants submit the following amendments and remarks for consideration by the Examiner and entry of record in the above-identified patent application.

**AMENDMENT TO THE SPECIFICATION**

On page 1 at the first line following the title, please insert the following section:

**Reference to Related Application**

This application is a divisional of Application No. 10,147,270, filed May 15, 2002, now  
6,682,992  
issued as U.S. Patent No. (number not yet assigned).

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Dated:

Maryann Luisi  
Maryann Luisi

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